

#24/F(2)  
MURP  
8/4/99

- 1 -

Docket: 0756-1638

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on July 26, 1999.

Karen M. Johnson  
for Julie Helm

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT application of  
Hisashi OHTANI et al.



Serial No. 08/807,737 ) Art Unit: 2813

Filed: February 27, 1997 ) Examiner: M. Sulsky

For: METHOD FOR MANUFACTURING )  
SEMICONDUCTOR DEVICE )

DO NOT  
Enter  
6/5/99

**AMENDMENT AFTER FINAL**

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed February 24, 1999, please amend the above-identified application as follows.

07/30/1999 STEFERRA 00000024 08807737

01 FC:103  
02 FC:102

540.00 OP  
234.00 OP